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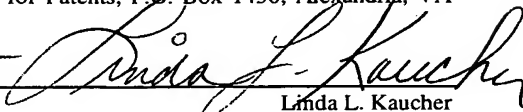
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Michel J. Adrien Baillargeon Examiner: David A. Vanore
Serial No.: 10/681,947 Atty. Dkt. No.: 2003P15605US
Filed: October 09, 2003 Art Unit No.: 2881
Title: Method and Apparatus for Detecting Low-Mass Ions

Certificate Of Mailing Pursuant To 37 CFR §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail on the date indicated below in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

8/13/05 
Date Linda L. Kaucher

LETTER TO OFFICIAL DRAFTSPERSON

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to M.P.E.P. Section 608.02, enclosed please find four sheets of formal drawings in the referenced case.

If there are any informalities with these drawings, Applicant requests issue of Form PTO-948 identifying the informalities noted by the Official Draftsperson.

The Commissioner is authorized to charge any fees in connection with this paper to Deposit Account No. 19-2179.

Respectfully submitted,



Jose R. de la Rosa
Reg. No. 34,810

Date: 8-3-05

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